



Certificate of Presentation

We hereby certify that the work

TCAD Simulation of Ultra-thin Body and Buried Oxide SOI MOSFET

by

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was presented at the XIV Workshop on Semiconductors and Micro & Nano Technology, in Campinas-SP, held on April 11-12, 2019.

A handwritten signature in blue ink, reading "Jacobus Swart", written over a horizontal line.

Dr. Jacobus Swart
SEMINATEC 2019 General Chair